Emission and Absorption Quantum Noise Measurement with an On-Chip Resonant Circuit

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Using a quantum detector, a superconductor-insulator-superconductor junction, we probe separately the emission and absorption noise in the quantum regime of a superconducting resonant circuit at equilibrium. At low temperature the resonant circuit exhibits only absorption noise related to zero point fluctuations, whereas at higher temperature emission noise is also present. By coupling a Josephson junction, biased above the superconducting gap, to the same resonant circuit, we directly measure the noise power of quasiparticles tunneling through the junction at two resonance frequencies. It exhibits a strong frequency dependence, consistent with theoretical predictions.

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Whereas electrical noise has been extensively studied at low frequency in various systems [1], going from macroscopic to mesoscopic scales, and is now relatively well understood, investigation of high frequency noise is much more recent. Of particular interest is the frequency range of the order of or higher than the applied voltage $V$ or temperature $T$ characteristic energy scales. Current fluctuations in this quantum regime acquire a frequency dependence with signatures of the relevant energy scales $k_B T$ and $eV$. Thus current fluctuations has been found to increase linearly with frequency above $k_B T / h$ [2,3]. Similarly, the excess noise, i.e., the difference between the noise at a given bias and the noise at equilibrium, measured in the limit $eV \gg k_B T$, has been found to decrease linearly with frequency and go to zero at frequency $eV / h$ in diffusive wires [4], tunnel junctions [5], and quantum point contacts [6]. In the quantum regime, noise can be described in terms of exchange of photons of energy $\hbar \nu$ between the source and the noise detector. Depending on whether photons are emitted or absorbed by the source, one measures emission noise (corresponding to negative frequencies) and absorption noise (corresponding to positive frequencies) [7]. This difference between emission and absorption processes is well known in quantum optics but difficult to observe in electronic devices, since most classical amplifiers exchange energy with the measured device and allow only the detection of a combination of emission and absorption noise [8].

To measure nonsymmetrized noise, i.e., distinguish between emission and absorption, one can use a quantum detector [7,9]. Different realizations of such a detection scheme have been implemented by using, e.g., quantum bits [10], quantum dots [11,12], a superconductor-insulator-superconductor (SIS) tunnel junction [13,14], or a superconducting resonator [15]. Because of the difficulty to extract the equilibrium noise contribution, this type of measurement has been done so far only for the excess noise.

In this work, we have embedded the tested device, a Josephson junction, in an on-chip superconducting resonant circuit, as in Refs. [15,16], and incorporated a quantum detector, a SIS junction, in the same circuit. We thus detect, in the quantum regime $\hbar \nu \gg k_B T$, the emission and absorption noise of the resonator at equilibrium and the excess noise of the probed device at the resonance frequencies. At the frequencies probed in the experiment, at low temperature the resonator does not emit noise, whereas it shows absorption noise related to its zero point fluctuations. This technique also allows a direct extraction of the excess noise power of quasiparticles tunneling through a Josephson junction at 28.4 and 80.2 GHz, the resonance frequencies of the resonator.

The probed device consists of two coupled coplanar transmission lines. Each transmission line is connected to the ground plane via a superconducting tunnel junction of size $240 \times 150 \text{ nm}^2$ and consists of two sections of the same length $l$ but different widths, thus different characteristic impedances $Z_1 = 110 \Omega$ and $Z_2 = 25 \Omega$ [Fig. 1(a)]. Because of the impedance mismatch, the transmission line acts as a quarter wavelength resonator, with resonances at frequency $\nu_n = n\nu/4l = \nu_{v1}$, with $\nu$ the propagation velocity and $n$ an odd integer [16]. The two transmission lines are close to one another to provide a good coupling at resonance and are terminated by on-chip Pt resistors. The junctions have a SQUID geometry with different areas to tune separately their critical currents with a magnetic flux. The junctions and the resonator are fabricated in aluminum (superconducting gap $\Delta = 260 \mu\text{eV}$) on an oxidized silicon wafer. The system is thermally anchored to the cold finger of a dilution refrigerator of base temperature 20 mK and measured through filtered lines with a standard low frequency lock-in amplifier technique.

Hereafter we call one junction the detector and the other the source. Coupling the detector to the source with a resonant circuit has two main effects on the detector. First, when the source is not biased, the $I(V)$ characteristic of the detector is modified by the resonator. This allows extracting the noise of the resonant circuit at equilibrium. Second, when the source is biased the detector is also sensitive to the source noise.
First, we neglect the effect of the source junction, on which no bias voltage is applied. The $I(V)$ characteristic of a small Josephson junction depends on the impedance of its electromagnetic environment [17]. For the case of a superconducting transmission line resonator [16], resonances appear in the subgap region $V_D < 2\Delta/e$ due to the excitation of the resonator modes by the ac Josephson effect [18,19]. These resonances are related to the real part of the impedance $Z(\nu)$ seen by the junction:

$$I(V) = \text{Re}[Z(2eV/h)]I_C^2/2V,$$

with $I_C = \pi\Delta/(2eR_F)$ [18] the critical current and $R_F = 18.7k\Omega$ the normal state resistance of the junction. Equation (1) can be derived as the effect of the electromagnetic environment on the tunneling of Cooper pairs through the Josephson junction [17] or by writing that the dc power provided by the voltage source to the Josephson junction is equal to the ac power dissipated by $\text{Re}[Z(\nu)]$ due to the ac Josephson effect at the Josephson frequency $\nu = 2eV/h$. Figure 1(b) shows the $I_C(V)$ characteristic of the junction in the subgap region for $I_C$ maximized with magnetic flux. By using Eq. (1) the subgap resonances allow us to extract the real part of the impedance seen by the junction. It exhibits peaks at frequencies $\nu_{1,2,3} = 28.4, 54.9, \text{and} 80.2$ GHz. With a length $l = 1$ mm the first resonance was expected at 30 GHz. We attribute the difference with the measured resonance frequency to the capacitances of the junctions, of the order of 3.5 fF, which shift the resonance. The relatively low quality factors $Q_n$, typically 10, are related to the direct connection of the biasing circuit to the transmission line. The fact that we see resonances at frequencies $\nu_n = n\nu/4l$, with $n$ not only odd but also even, is attributed to the ratio $Z_1/Z_2 < 10$ of the impedances of the transmission lines.

The resonant circuit coupled to the junction also leads to a photoassisted tunneling (PAT) quasiparticle current through the detector. To probe this effect the magnetic flux is adjusted to minimize the critical current of the detector. The dependence of quasiparticles tunneling in SIS junctions versus irradiation with microwave photons has been widely used for making mixers [20]. More recently, SIS junctions have been used as quantum detectors of noise in mesoscopic physics [13,14]. The PAT current through the detector as a function of bias voltage $V_D$ and non-symmetrized spectral density of voltage noise $S_V(\nu)$ across the junction [9,17] reads for $k_BT \ll eV_D$ and small voltage noise $S_V(\nu)$:

$$I_{\text{PAT}}(V_D) = \int_0^\infty d\nu \left( \frac{e^2}{h \nu} \right)^2 S_V(-\nu)I_{QP,0}(V_D + \frac{\hbar \nu}{e}) + \int_0^{eV_D/h} d\nu \left( \frac{e^2}{h \nu} \right)^2 S_V(\nu)I_{QP,0}(V_D - \frac{\hbar \nu}{e}) - \int_{-\infty}^{eV_D/h} d\nu \left( \frac{e^2}{h \nu} \right)^2 S_V(\nu)I_{QP,0}(V_D),$$

with $I_{QP,0}(V_D)$ the $I(V)$ characteristic of the detector without an electromagnetic environment. The first term of Eq. (2) is related to the emission noise and the second to the absorption noise, and the third renormalizes the elastic current. When $|V_D| < 2\Delta/e$, due to the superconducting density of states, $I_{QP,0}(V_D) = 0$ so that only emission noise is detected for frequencies higher than $(2\Delta - eV_D)/h$. For $|V_D| > 2\Delta/e$ the detector is mainly sensitive to absorption noise. To probe more accurately the small effect of the resonant circuit on the detector, we modulate at 13.3 Hz $V_D$ and detect by a lock-in technique $dI/dV_D$ at different temperatures [Fig. 2(a)]. At low temperature, on top of the expected $dI/dV_D$ curve of the detector, we see peaks [Fig. 2(a)] at $eV_D = 2\Delta + h\nu_n$ with $\nu_n$ the resonance frequencies of the circuit coupled to the detector. No such peaks are detected for $eV_D < 2\Delta$, but, at a higher temperature between 200 mK and 1 K, a peak at $eV_D = 2\Delta - h\nu_1$ appears and grows with temperature. The position in $V_D$ of the peaks changes due to the temperature dependence of the superconducting gap. Higher temperatures were not considered due to the strong temperature dependence of the SIS detector for $T > 1$ K. These peaks in the $dI/dV$ characteristics of the detector are attributed to its sensitivity to the voltage fluctuations of the resonator:

$$S_V(\nu, T) = 2\text{Re}[Z(\nu)h\nu/\left(1 - \exp(-h\nu/k_BT)\right)].$$

Equation (3) describes the crossover between thermal noise at low frequency and quantum noise related to the zero point fluctuations of the electromagnetic field. The

\[FIG. 1 (color online). (a) Sketch of the sample, with $a = 5 \mu m$, $b = 100 \mu m$, and $l = 1 \text{ mm}$. The two transmission lines are terminated by on-chip Pt resistors ($R = 825 \Omega$). (b) Lower curve: $I(V)$ of the detector in the subgap region with $I_C$ maximized by adjusting the magnetic flux. Upper curve: The real part of the detector as a function of bias voltage $V_D$ and $S_V(\nu)$ across the junction [9,17].\]
Only absorption noise is detected below 0.4 K. The solid line corresponds to the theoretical prediction [Eq. (3)]. Only absorption noise is detected below 0.4 K.

Resonances of $\text{Re}[Z(\nu)]$ yield noise peaks at frequencies $+\nu_n$ (absorption, with $\nu_n > 0$) and $-\nu_n$ (emission). At low $T$ only peaks in absorption are predicted, whereas when $T$ increases peaks in emission should appear. For $eV_D < 2\Delta$ only the first term in Eq. (2) is nonzero. For a peaked emission noise at $-\nu_n$, approximating the integral by a sum and taking $\delta\nu_n = 1.06\nu_n/Q_n$ [21] extracted from Fig. 1(b), yields

$$I_{\text{PAT}}(V_D) = \sum_n \frac{e^2S_0(-\nu_n)^2}{(\hbar\nu_n)^2} I_{\text{QP},0}(V_D - \frac{\hbar\nu_n}{e})$$

(4)

Only the absorption term in Eq. (2) leads to peaks in $dI/dV$ for $V_D > 2\Delta/e$:

$$I_{\text{PAT}}(V_D) = \sum_n \frac{e^2S_0(\nu_n)^2}{(\hbar\nu_n)^2} I_{\text{QP},0}(V_D + \frac{\hbar\nu_n}{e})$$

(5)

From Eqs. (4) and (5) we extract the emission and absorption voltage fluctuations of the resonant circuit at $\nu_1 = 28.4$ GHz at different $T$ [Fig. 2(b)]. To do so, we integrate the corresponding peak in $dI/dV_D$, at $V_D = (2\Delta - \hbar\nu_1)/e$ for emission and $V_D = (2\Delta + \hbar\nu_1)/e$ for absorption, to obtain the value of $I_{\text{PAT}}$. $\delta\nu_1 = 6.66$ GHz is extracted from Fig. 1(b), and the current $I_{\text{QP},0}(V)$ is measured from the $I(V)$ of the detector at temperature $T$ [22]. The same treatment is done for the absorption noise at $\nu_1 = 80.2$ GHz and leads to $S_\nu(\nu_3) = 0.062 \pm 0.005$ nV²/Hz between 20 and 950 mK, consistent with the expected value 0.064 nV²/Hz. The $T$ dependence of voltage fluctuations agrees quantitatively with theoretical predictions [Eq. (3)]. Deep in the quantum regime ($h\nu_1 \gg k_BT$) the voltage fluctuations at equilibrium are dominated by the zero point fluctuations of the electromagnetic field and do not exhibit any emission noise. For $h\nu_1 \approx k_BT$ the crossover to thermal noise is visible.

We have neglected so far the source junction. When it is biased it can emit noise, which couples to the detector via the resonant circuit. To probe the emission of the source the detector is biased at $V_D < 2\Delta/e$, and the source bias voltage $V_S$ is modulated so as to detect by a lock-in technique only the source contribution to the PAT current, i.e., $\partial I_{\text{PAT}}/\partial V_S$. This quantity, numerically integrated, leads to $I_{\text{PAT}}(V_S)$. To characterize the coupling between source and detector, we use the ac Josephson effect of the source for calibration. In Fig. 3, the PAT current through the detector versus $V_S$ is shown at two detector voltages $V_{D1} = 450$ $\mu$V and $V_{D2} = 300$ $\mu$V. In this regime where the detector is irradiated by the Josephson current at frequency $\nu = 2eV_S/h$, the PAT current reads [23]

$$I_{\text{PAT}}(V_D) = e^2|Z(\nu)|^2 I_{\text{QP}}^2(V_D + \hbar\nu/e)/(4\hbar^2

(6)

with $I_C$ the critical current of the source junction, $Z(\nu)$ the transimpedance measuring the coupling between the source and the detector, and $I_{\text{QP}}(V_D)$ the IV characteristic of the detector. Using Eq. (6) we can extract from the curve measured at $V_{D1}$ the coupling $|Z(\nu)|^2$ (Fig. 3). It exhibits resonances at the same frequencies as the resonator. This scheme allows a rather strong coupling, proportional to the quality factor of the resonance of $|Z(\nu)|^2$, for a finite number of frequencies. This contrasts with previous experiments using a capacitive coupling between the source and detector.
I compare these results to the theoretical prediction: spectrum from Fig. 4. When \( V_D / C_{23n} \) and to the noise integrated over the detection bandwidth \( \delta \nu_n \), the frequency dependence is well reproduced. This is a direct quantitative measurement in the quantum regime \( h \nu \gg k_B T \) of the quantum noise associated with the quasiparticles tunneling.

In conclusion, we have measured the emission and absorption noise of a resonant circuit at equilibrium by coupling it to a quantum detector, a SIS junction. At low temperature the circuit exhibits only absorption noise related to the zero point fluctuations of the electromagnetic field. At higher temperature emission noise is also present. The design of the resonant circuit allows us to couple another device to the detector and to measure quantitatively its noise at the resonances of the resonant circuit with an accuracy proportional to their quality factors. For a Josephson junction biased above the superconducting gap, it was thus possible to probe quantitatively the quasiparticle current noise at 28.4 and 80.2 GHz and, in particular, its strong frequency dependence. This technique can be used to probe quantum noise of relatively resistive mesoscopic devices at high frequency.

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FIG. 4 (color online). (a) PAT current through the detector versus \( V_s \) at \( V_{D1} \) and \( V_{D2} \). The \( I(V) \) of the source is also shown. (b) Extracted emission noise power at \( V_1 = 28.4 \) GHz and \( V_3 = 80.2 \) GHz. For comparison the expected noise power is plotted (dashed curves) along with the noise average over the bandwidth \( \delta \nu_n \) of detection (dotted lines). The agreement is within 5%. The expected zero frequency emission noise power is plotted (dashed-dotted line).

detector [13,14], leading to a relatively small coupling over a wide range of frequencies.

When \( e V_S \simeq 2 \Delta \), the noise due to the tunneling of quasiparticles is probed. The PAT current is shown in Fig. 4 for two values of detector bias. We use Eq. (4), with \( S_{\nu}(\nu) = \left| Z_{\nu}(\nu) \right|^2 S_{QP}(\nu, V_S) \) and \( \delta \nu_n \) the width of the resonances from Eq. 4. When \( V_D < 2 \Delta / e \), only the frequencies higher than \( (2 \Delta - e V_D)/h \) need to be considered in the sum. Consequently, for \( V_D = V_{D1} \) the detector is mainly sensitive to the noise at frequencies \( \nu_1 \) and \( \nu_3 \), whereas for \( V_D = V_{D2} \) only the noise at \( \nu_3 \) is detected. The noise at \( \nu_1 \) is thus extracted from \( I_{PAT}(V_{D1}) - I_{PAT}(V_{D2}) \). One then obtains the spectral density of quasiparticle noise in emission at \( \nu_1 \) and \( \nu_3 \) (Fig. 4). We compare these results to the theoretical prediction:

\[
S_{\nu_1}(\nu, V_S) = e \left[ \frac{I_{QP}(h \nu / e + V_S)}{1 - e^{-\beta (h \nu / e + V_S)}} + \frac{I_{QP}(h \nu / e - V_S)}{1 - e^{-\beta (h \nu / e - V_S)}} \right]
\]

and to the noise integrated over the detection bandwidth \( \delta \nu_n \). The agreement is within 5% in amplitude with this last quantity, and the frequency dependence is well reproduced. This is a direct quantitative measurement in the quantum regime \( h \nu \gg k_B T \) of the quantum noise associated with the quasiparticles tunneling.

In conclusion, we have measured the emission and absorption noise of a resonant circuit at equilibrium by coupling it to a quantum detector, a SIS junction. At low temperature the circuit exhibits only absorption noise related to the zero point fluctuations of the electromagnetic field. At higher temperature emission noise is also present. The design of the resonant circuit allows us to couple another device to the detector and to measure quantitatively its noise at the resonances of the resonant circuit with an accuracy proportional to their quality factors. For a Josephson junction biased above the superconducting gap, it was thus possible to probe quantitatively the quasiparticle current noise at 28.4 and 80.2 GHz and, in particular, its strong frequency dependence. This technique can be used to probe quantum noise of relatively resistive mesoscopic devices at high frequency.

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[21] \( \delta \nu_n \) multiplied by the amplitude of the resonance peak is equal to the area of the peak.
[22] The change in the \( I(V) \) of the detector due to the resonator being small, taking \( I(V) \) at temperature \( T \) instead of \( I_{QP}(V) \) at \( T \) in Eqs. (4) and (5), leads to the same result in first order.